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| APPLICATION NO.   | FILING DATE     | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO.     | CONFIRMATION NO. |  |
|---|-----------------|----------------------|-------------------------|------------------|--|
| 09/557,108  | 04/24/2000      | Jiang Hsieh          | 15-CT-5344 8980         |                  |  |
| 7:  | 7590 03/23/2004 |                      | EXAMI                   | EXAMINER         |  |
| John S Beulick  |                 |                      | KIM, CHONG R            |                  |  |
| Armstrong Teasdale LLP One Metropolitan Square Suite 2600 |                 |                      | ART UNIT                | PAPER NUMBER     |  |
| St Louis, MO 63102-2740                                   |                 |                      | 2623                    |                  |  |
|   |                 |                      | DATE MAILED: 03/23/2004 | (2               |  |

Please find below and/or attached an Office communication concerning this application or proceeding.

|   | Application No.   | Applicant(s)   |  |  |  |  |
|---|---|--|--|--|--|--|
|   | 09/557,108  | HSIEH, JIANG   |  |  |  |  |
| Office Action Summary   | Examiner  | Art Unit   |  |  |  |  |
|   | Charles Kim   | 2623   |  |  |  |  |
| The MAILING DATE of this communication app<br>Period for Reply  | ears on the cover sheet with the c  | orrespondence address  |  |  |  |  |
| A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). | 6(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE | nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133). |  |  |  |  |
| Status  |   |  |  |  |  |  |
| 1)⊠ Responsive to communication(s) filed on 23 January 2003.  |   |  |  |  |  |  |
| 2a)⊠ This action is <b>FINAL</b> . 2b)□ This  | This action is <b>FINAL</b> . 2b) This action is non-final.   |  |  |  |  |  |
| 3) Since this application is in condition for allowance except for formal matters, prosecution as to the ments is   |   |  |  |  |  |  |
| closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.   |   |  |  |  |  |  |
| Disposition of Claims   |   |  |  |  |  |  |
| 4)⊠ Claim(s) <u>1-32</u> is/are pending in the application.   |   |  |  |  |  |  |
| 4a) Of the above claim(s) is/are withdrawn from consideration.  |   |  |  |  |  |  |
| 5) Claim(s) is/are allowed.   |   |  |  |  |  |  |
| 6)⊠ Claim(s) <u>1-7,9,11-13,15-21,23,25-27 and 29-32</u> is/are rejected.   |   |  |  |  |  |  |
| 7) Claim(s) <u>8,10,14,22,24 and 28</u> is/are objected t   |   |  |  |  |  |  |
| 8) Claim(s) are subject to restriction and/or   | election requirement.   |  |  |  |  |  |
| Application Papers  |   |  |  |  |  |  |
| 9) The specification is objected to by the Examiner   | •   |  |  |  |  |  |
| 10)⊠ The drawing(s) filed on <u>01 August 2003</u> is/are: a)□ accepted or b)⊠ objected to by the Examiner.   |   |  |  |  |  |  |
| Applicant may not request that any objection to the d   | Irawing(s) be held in abeyance. See   | e 37 CFR 1.85(a).  |  |  |  |  |
| Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).  |   |  |  |  |  |  |
| 11)☐ The oath or declaration is objected to by the Exa  | aminer. Note the attached Office  | Action or form PTO-152.  |  |  |  |  |
| Priority under 35 U.S.C. § 119  |   |  |  |  |  |  |
| 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) □ All b) □ Some * c) □ None of:   |   |  |  |  |  |  |
| 1. Certified copies of the priority documents have been received.   |   |  |  |  |  |  |
| 2. Certified copies of the priority documents have been received in Application No  |   |  |  |  |  |  |
| 3. Copies of the certified copies of the priority documents have been received in this National Stage   |   |  |  |  |  |  |
| application from the International Bureau (PCT Rule 17.2(a)).   |   |  |  |  |  |  |
| * See the attached detailed Office action for a list of the certified copies not received.  |   |  |  |  |  |  |
| •   |   |  |  |  |  |  |
| Attachment(s)   |   |  |  |  |  |  |
| 1) Notice of References Cited (PTO-892)  4) Interview Summary (PTO-413)   |   |  |  |  |  |  |
| Paper No(s)/Mail Date  Notice of Draftsperson's Patent Drawing Review (PTO-948) Paper No(s)/Mail Date  Notice of Informal Patent Application (PTO-152)  |   |  |  |  |  |  |
| Paper No(s)/Mail Date   | 6) Other:   | with application (LTO-102)   |  |  |  |  |
| S. Patent and Trademark Office  |   |  |  |  |  |  |

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#### **DETAILED ACTION**

### Response to Amendment and Arguments

- 1. Applicant's amendment filed on January 23, 2003 has been entered and made of record.
- 2. Applicant's arguments with respect to claims 1-28 have been considered but are moot in view of the new ground(s) of rejection.

### **Drawings**

3. The drawings are objected to under 37 CFR 1.83(a). The drawings must show every feature of the invention specified in the claims. Therefore, the "curved plane of reconstruction" must be shown or the feature(s) canceled from the claim(s). No new matter should be entered.

A proposed drawing correction or corrected drawings are required in reply to the Office action to avoid abandonment of the application. The objection to the drawings will not be held in abeyance.

## Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

4. Claims 30 and 32 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter which was not

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described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention.

Referring to claim 30, the phrase "the more than two conjugate samples that are located on only one side of the curved plane of reconstruction" in lines 4-5 is not supported by the applicant's specification. The closest language to this feature appears to be on page 7, lines 13-15 of the applicant's specification, where it states "In one embodiment of the present invention, to use x1 and x2 to estimate x, extrapolation is used as represented by line 52". In this case, it appears that only two samples (x1 and x2) used for estimating the at least one projection are located on only one side of the curved plane of reconstruction. Therefore, the applicant's specification does not provide support in regards to "the more than two conjugate samples that are located on only one side of the curved plane of reconstruction" as claimed. A similar rejection is applicable to claim 32.

### Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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5. Claims 1-5, 9, 11, 15-19, 23, 25 are rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Taguchi et al., U.S. Patent No. 5,974,108 ("Taguchi") and Nambu et al., U.S. Patent No. 6,196,715 ("Nambu").

Referring to claim 1, Taguchi discloses a method for imaging an object with a computed tomographic imaging system, comprising the steps of:

- a. helically scanning the object with a multi-slice CT imaging system to acquire attenuation measurements of the object, the measurements including more than two conjugate samples (col. 4, line 61 to col. 5, line 9. Note that the "groups of real data" in col. 5, line 6 is interpreted as being analogous to more than two conjugate samples; since two data samples are selected from the group, see col. 5, lines 4-6. See also col. 11, lines 48-49), wherein a difference between a view angle of one of the more than two conjugate samples and a view angle of any one of the remaining conjugate samples of the more than two conjugate samples is nΠ, wherein n is an integer greater than zero (col. 10, lines 63-67)
- b. estimating at least one projection along a plane of reconstruction of the object using the attenuation measurements of the object, including the more than two conjugate samples [col. 11, lines 48-60 and figure 15. Taguchi explains that the interpolated data is determined using more than two (2n+1) samples, wherein the interpolated data is supplied to the image reconstructor in order to reconstruct (project) the image (col. 12, lines 22-25)]
- c. filtering and backprojecting the attenuation measurements of the object, including the more than two conjugate samples, to reconstruct at least one image slice of the object [col. 25, lines 1-12 and col. 26, lines 19-21. Note that the filtering is performed in the interpolator (29) and the backprojecting is performed in the image reconstructor (31) of figure 11].

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Taguchi does not explicitly disclose a curved plane of reconstruction. However, this feature was exceedingly well known in the art. For example, Nambu discloses a curved plane of reconstruction for which at least one projection is estimated (figure 43).

Taguchi and Nambu are both concerned with CT imaging systems. Taguchi is concerned with obtaining a high quality image (Taguchi, col. 4, lines 36-38). Nambu's method suppresses unwanted artifacts in the image, and thereby enhances the image quality (Nambu, col. 3, lines 41-44). Therefore, it would have been obvious to modify Taguchi's plane of reconstruction so that it is a curved plane of reconstruction, as taught by Nambu, in order to enhance the imaging process.

Referring to claim 2, Taguchi further discloses that the more than two conjugate samples are located within a predetermined distance from the plane of reconstruction of the object [col. 2, lines 23-29. Note that the "target slicing location" in line 27 is interpreted to mean the plane of reconstruction, since the image is produced at that location, col. 6, lines 28-30. It is also noted that the samples (arrows) are located within a predetermined distance from the plane of reconstruction (target slicing location) in figure 4B].

Taguchi does not explicitly disclose a curved plane of reconstruction. However, this feature is taught by Nambu, as noted above.

Referring to claim 3, Taguchi further discloses that the CT imaging system has N detector rows (col. 14, line 66), and further comprises the step of selecting a helical pitch P:1 for the helical scan, where P is a non-integer less than N (col. 15, line 33. Note that N=4 and a helical pitch of 2.5 is selected).

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Referring to claim 4, Taguchi further discloses that N=4 and P=2.5 (col. 14, line 66 and col. 15, line 33 and figure 26).

Referring to claim 5, Taguchi further discloses a step of applying a non-linear interpolation to the attenuation measurements prior to the filtering and backprojecting (col. 24, lines 34-45 and figure 45).

Referring to claim 9, Taguchi further discloses that applying a non-linear interpolation to the attenuation measurements comprises combining weighted interpolated measurements with weighted extrapolated measurements (col. 11, lines 20-28 and col. 12, lines 12-20).

Referring to claim 11, Taguchi further discloses the step of applying a set of weights to the attenuation measurements prior to the filtering and backprojecting (col. 10, lines 45-57. Note that the weights are applied as the interpolation proceeds in lines 45-46, and is therefore applied prior to the filtering and backprojecting; since the interpolation is applied prior to the filtering and backprojecting as disclosed above).

Claims 15-19, 23, 25 recite a system that corresponds to the method of claims 1-5, 9, 11 respectively. Arguments analogous to those presented above with respect to claims 1-5, 9, 11 are applicable to claims 15-19, 23, 25. The system for performing Taguchi and Nambu's method is inherent in their teaching.

6. Claims 6-7, 12-13, 20-21, 26-27 are rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Taguchi et al., U.S. Patent No. 5,974,108 ("Taguchi") and Nambu et al., U.S. Patent No. 6,196,715 ("Nambu"), further in view of Berlad, U.S. Patent No. 5,513,120 ("Berlad").

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lines 1-19).

Referring to claim 6, Taguchi and Nambu fail to teach applying a Lagrange interpolation.

Berlad teaches a step of applying a Lagrange interpolation to a radiation image (col. 4,

Taguchi, Nambu, and Berlad are all concerned with image processing systems. Berlad's method provides an interpolated image where the texture of the image does not vary as a function of location and the signal content and signal-to-noise ratio are substantially the same after the interpolation (Berlad, col. 2, lines 16-29). Berlad further explains that the non-linear Lagrange interpolation technique minimizes texture artifacts, thereby producing an accurate interpolated image (Berlad, col. 4, lines 25-44). The ordinary artisan would have been motivated

to include the teachings of Berlad in the method of Taguchi and Nambu, in order to reconstruct a

radiation image and improving diagnosis. Therefore, it would have been obvious to modify the

interpolation of Taguchi and Nambu so that it is a Lagrange interpolation, as taught by Berlad.

radiation image based on an accurate interpolated image, thereby enhancing the resultant

Referring to claim 7, Berlad further teaches the step of applying third order Lagrange interpolation weights to a radiation image (col. 4, lines 48-50. Note that the "four interpolation coefficients as derived from a four point cubic Lagrange polynomial" in lines 48-50 is interpreted to mean third order Lagrange interpolation weights).

Taguchi teaches applying a non-linear interpolation to the attenuation measurements from four detector rows (col. 14, line 66 and col. 24, lines 34-45). Therefore, the combination of Taguchi, Nambu, and Berlad teach applying a third order Lagrange interpolation weights to measurements from four detectors.

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Referring to claim 12, Taguchi and Nambu fail to teach the step of applying Lagrange weights to the attenuation measurements.

Berlad teaches the step of applying Lagrange weights to a radiation image (col. 48-50. Note that the "four interpolation coefficients" in line 48 is interpreted to mean Lagrange weights).

Taguchi, Nambu, and Berlad are all concerned with image processing systems. Berlad's method provides an interpolated image where the texture of the image does not vary as a function of location and the signal content and signal-to-noise ratio are substantially the same after the interpolation (Berlad, col. 2, lines 16-29). Berlad further explains that the non-linear Lagrange interpolation technique minimizes texture artifacts, thereby producing an accurate interpolated image (Berlad, col. 4, lines 25-44). The ordinary artisan would have been motivated to include the teachings of Berlad in the method of Taguchi and Nambu, in order to reconstruct a radiation image based on an accurate interpolated image, thereby enhancing the resultant radiation image and improving diagnosis. Therefore, it would have been obvious to modify the set of weights of Taguchi and Nambu, so that they are Lagrange weights, as taught by Berlad.

Referring to claim 13, see the rejection of at least claim 7 above.

Claims 20-21, 26-27 recite a system that corresponds to the method of claims 6-7, 12-13 respectively. Arguments analogous to those presented above with respect to claims 6-7, 12-13 are applicable to claims 20-21, 26-27. The system for performing Taguchi, Nambu, and Berlad's method is inherent in their teaching.

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7. Claims 29 and 31 are rejected under 35 U.S.C. 103(a) as being unpatentable over the combination of Taguchi et al., U.S. Patent No. 5,974,108 ("Taguchi") and Nambu et al., U.S. Patent No. 6,196,715 ("Nambu"), further in view of King et al., U.S. Patent No. 5,233,518 ("King").

Referring to claim 29, Taguchi and Nambu fail to explicitly disclose the step of applying interpolation and extrapolation to determine weights to be applied to the attenuation measurements. However, this feature was exceedingly well known in the art. For example, King discloses the step of applying interpolation and extrapolation to determine weights to be applied to attenuation measurements (col. 3, line 61-col. 4, line 2).

Taguchi, Nambu, and King are all concerned with CT imaging systems. King's method reduces skew artifacts in the reconstructed image, thereby enhancing the image reconstruction process (King, col. 3, lines 52-53). Therefore, it would have been obvious to include King's teaching in the method of Taguchi and Nambu, in order to enhance the image reconstruction process.

Referring to claim 31, see the rejection of at least claim 29 above.

### Allowable Subject Matter

8. Claims 8, 10, 14, 22, 24, and 28 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

### Conclusion

9. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, THIS ACTION IS MADE FINAL. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Charles Kim whose telephone number is 703-306-4038. The examiner can normally be reached on Mon thru Thurs 8:30am to 6pm and alternating Fri.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amelia Au can be reached on 703-308-6604. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

ck

March 18, 2004

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